Electronic Patent Application Fee Transmittal							
Application Number:	10586445						
Filing Date:	17-Jul-2006						
Title of Invention:	Method for predicting precipitation behavior of oxygen in silicon single crystal, method for determining production parameter of silicon single crystal, and storage medium for storing program for predicting precipitation behavior of oxygen in silicon single crystal						
First Named Inventor/Applicant Name:	Kozo Nakamura						
Filer:	Gerald T. Shekleton/Richard Sensenbrenner						
Attorney Docket Number:	1110/97825						
Filed as Large Entity							
U.S. National Stage under 35 USC 371 Filing I	ee	s					
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:							
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							
Extension-of-Time:							
Extension - 1 month with \$0 paid		1251	1	130	130		

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	810	810
	Tot	940		